

FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)ATTY DOCKET NO.
OGOH-053ASERIAL NO. 10/608,000
Rule 1.53(b) Div of SN 09/700,132 filed November 9,APPLICANT
Shin-Itsu TAKEHASHI et al.FILING DATE
June 20, 2003GROUP
2815 2418

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
MT	5,089,883	02/1992	Satoh et al.	257	388	_____
	5,471,080	11/1995	Satoh et al.	257	344	_____
	5,880,015	03/1999	Mata	438	685	_____
	5,977,586	11/1999	Crisenza et al.	257	326	_____
	5,989,987	11/1999	Gardner et al.	438	305	_____
	5,981,383	11/1999	Liu et al.	438	655	_____
	6,069,387	05/2000	Gardner	257	344	_____
✓	6,284,813	09/2001	Subrahmanyam et al.	438	307	_____

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	NO TRANSLATION YES
MT	3-61-38975	02/1988	Japan	257	344	✓
	3-63-9154	01/1998	Japan	438	158	✓
	4-2-228727	09/1990	Japan	438	305	✓
	4-5-21454	01/1993	Japan	H01L	21/338	✓
	4-5-243261	09/1993	Japan	257	408	✓
	4-6-260645	09/1994	Japan	H01L	29/784	✓
✓	3-60-127781	07/1985	Japan	H01L	29/78	✓

OTHER DOCUMENT(S) (Including Author, Title, Date, Patent Page, Etc.)

MT	"Spacer Formation on Electrodes with Non-Vertical Sidewalls," IBM Technical Disclosure Bulletin, Nov. 1, 1984, Vol. 27, No. 6.
	TDB-ACC-No. NN84113464, pp 3464-66.

EXAMINER: *Marlison Rios*

DATE CONSIDERED: 2/9/04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 602; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.